

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Mei Wen et al.  
Serial No. : 10/676,208  
Filed : October 1, 2003  
For : METAL DEPOSITION PROCESS WITH PRE-CLEANING BEFORE ELECTROMECHANICAL DEPOSITION  
Examiner : Edna Wong  
Group Art Unit : 1753  
Customer No. : 41161  
  
Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Examiner's Office Action dated February 27, 2007, Applicants amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2.

**Amendments to the Claims** begin on page 3.

**Remarks** begin on page 7.